

## Effect of anisotropy constant distribution on domain wall motion

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Recently many researches on domain wall motion driven by spin polarized current and magnetic field have been done.[1~4] The high density non-volatile memory application as well as the reconfigurable logic was suggested for the application of current driven domain wall motion. However, for the realization of those electronic devices, the reduction of operation current is required. Such a low current cannot be achieved with widely used NiFe nanostrips, in which critical current density has been reported to be  $\sim 1.0 \times 10^8$  A/cm<sup>2</sup>. Much attention has been paid to the high perpendicular magnetic anisotropy (PMA) materials in order to obtain low operational current based on the report of recent theoretical results such as CoCrPt and Co/Pt multilayer.[5] However, experimental finding is not consistent with theoretical one.[6] This might be related with the intrinsic defect or peculiar property like uniaxial anisotropy constant ( $K_u$ ) in PMA materials. Specially, large  $K_u$  dispersion in PMA multilayer film was reported in the measurement of switching field, [7] which might provide some clue of this contradiction.

In this work, we examined the effect of  $K_u$  dispersion on domain wall motion driven by magnetic field or current. And hysteresis loops with varying  $K_u$  dispersions will be compared with experimental hysteresis loops.

Current induced magnetization dynamics are micromagnetically modeled by including spin transfer torque term in LLG equations.[4] Material parameters were  $M_s=400$ emu/cc,  $K_u=2.0 \times 10^6$ erg/cc, the exchange constant  $A=1.0 \times 10^{-6}$  erg/cm, spin polarization=0.5, damping constant=0.1, and non-adiabaticity  $\beta=0.01$ . The width, length, and thickness of the strips were 800 nm, 60 nm, and 5 nm, respectively. The size of a unit cell is 4 nm  $\times$  4 nm  $\times$  5 nm. The orientation of the easy axes for anisotropy is perfect perpendicular direction of nanowire. Current pulse width is 50 ns. Time step for LLG eq. is set to be 0.02 ps. Average terminal domain wall velocity was calculated as function of current density and magnetic field.

Fig. 1 shows the hysteresis loops with two different  $K_u$  standard deviations. With mean  $K_u$  of  $1.0 \times 10^6$  erg/cc, standard deviation of  $K_u$  is 0 erg/cc or  $1.0 \times 10^6$  erg/cc. There was a slight difference between coercivity ( $H_c$ ) out of plane and saturation field ( $H_s$ ) in plane in the hysteresis without  $K_u$  dispersion.  $H_c$  is same of  $H_s$  of  $\sim 2900$  Oe. When standard deviation of  $K_u$  was  $1.0 \times 10^6$  erg/cc,  $H_c$  was  $\sim 700$  Oe and  $H_s$  was  $\sim 7000$  Oe. As standard deviation of  $K_u$  increases,  $H_c$  decreases and  $H_s$  increases. From hysteresis loop, we can expect how large standard deviation of  $K_u$  is in the perpendicular magnetic materials.

Fig. 2 shows the domain wall velocity in field driven and current driven domain wall motion. As seen, critical magnetic field and critical current for domain wall motion were 470 Oe and  $\sim 1.7 \times 10^7$  A/cm<sup>2</sup> comp. It is well known that critical current with non-zero adiabaticity are zero in perfect nanowire track.[5] It is found that  $K_u$  distribution of nanowire plays a role of pinning potential to the domain wall motion.

Therefore reducing  $K_u$  dispersion in perpendicular magnetic material can be necessary for reducing critical current for the application of domain wall motion.

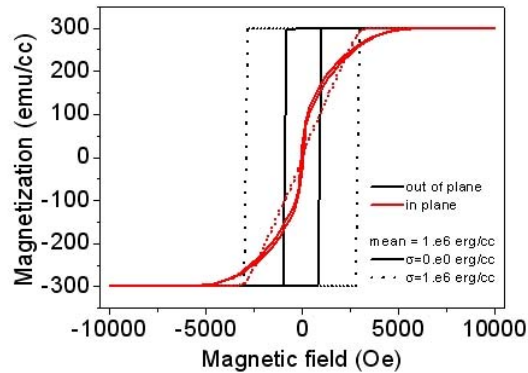


Fig. 1. Hysteresis loops of mean  $K_u$  of 1.06 erg/cc, standard deviation of (a)  $K_u = 0$ , (b)  $K_u = 1.06$  erg/cc.

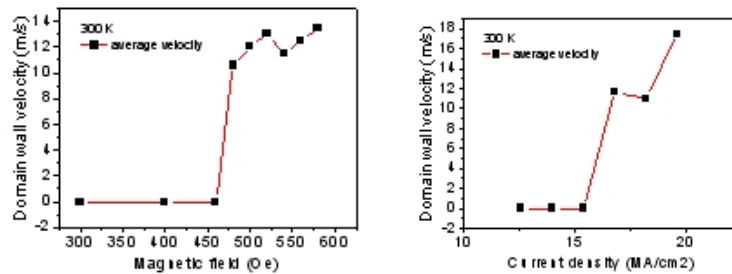


Fig. 2. domain wall velocity with magnetic field and current density of mean  $K_u$  of 1.06 erg/cc and standard deviation of  $K_u = 1.06$  erg/cc.

## References

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